

Dinage RCE/1756  
1/9  
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the Application of

Akifumi KAMIJIMA et al.

Application No.: 09/966,080

Filed: October 1, 2001

For: A METHOD FOR FABRICATING A RESIST  
PATTERN, A METHOD FOR PATTERNING A  
THIN FILM AND A METHOD FOR  
MANUFACTURING A MICRO DEVICE

Group Art Unit: 1756

Examiner: J. Ruggles

Docket No.: 110735

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

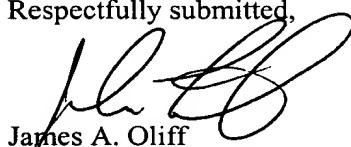
In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination.

Applicant(s) further request(s) entry and consideration of the submission filed December 15, 2003.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 150884 in the amount of  \$770.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

  
James A. Oliff  
Registration No. 27,075

John W. Fitzpatrick  
Registration No. 41,018

JAO:JWF/ldg

Date: February 10, 2004

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**DEPOSIT ACCOUNT USE  
AUTHORIZATION**  
Please grant any extension  
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